

Table of Contents

<i>Preface</i>	<i>xi</i>
Chapter 1 Non-modern Modern Microscopes	1
1.1 A Brief Excursion to History	2
1.2 Non-modern Modern Microscopes	6
1.2.1 Objectives: Achromats	10
1.2.2 Objectives: Apochromats	20
1.2.3 Achromats and apochromats water immersion objectives	37
1.2.4 Eyepieces, condensers and other components	41
1.2.4.1 Eyepieces	45
1.2.4.2 Condensers	49
1.2.4.3 Other equipment	70
1.2.5 Reflective light equipment	80
1.2.6 Old mass-produced Soviet microscopes and devices	81
1.2.6.1 Phase contrast devices	86
1.2.6.2 Reflected light device (OI-21) for the “Biolam” microscope	96
1.2.6.3 Fluorescent reflected-light device (OI-28) for the “Biolam” microscope	99
1.2.6.4 Measuring devices for budget microscopes	103
1.2.6.5 Polarizing microscopes and devices	107
1.2.6.6 Device for research by contact microscopy: OLK-2	115
1.2.7 Set of interesting, old Zeiss objectives	116
1.2.8 Old mass-produced American microscopes	117
1.3 Topical Reasoning	127
References	130
Chapter 2 Abstracts and Reviews	131
2.1 Group Design of Optical Instruments	131
2.1.1 Basic design	137
2.1.2 Aggregate-modular design	139
2.2 Design of Unified Systems of Optical Instruments and Functional Nodes	143
2.3 Brief Classification of Microscopic Objects	148

2.3.1	Brief description of some special “microscopic” objects	150
2.4	Short Description of Image in the Microscope	154
2.5	Main Types of Microscopes and Components of the Light Microscope	158
2.6	On the Need to Change Some Norms and Standards for Light Microscopes	158
2.6.1	On the current level of technology	158
2.7	Optical System of a Modern Microscope	169
2.7.1	Illumination system	170
2.7.2	The visual observation system	171
2.7.3	Objectives	173
2.7.4	Eyepieces	174
2.7.5	Recording system	175
2.8	Engineering Solutions of Optics for Visualization Systems of Light Microscopes	176
2.9	Examples of Principal Optical Designs of Some Kinds of Light Microscopes	182
2.10	Synthesis of the Optical Systems of Lens Objectives for Light Microscopes	182
2.10.1	Designing the optical layouts of microscope objectives	184
2.10.2	The simplest microscope objectives	188
2.10.3	The simplest microscope objectives with corrected lateral color aberration	188
2.10.4	The simplest microscope objectives with correction for two wavelengths or spectral regions “dualchromat” type	189
2.10.5	Microscope objectives with increased numerical apertures	190
2.10.6	Microscope objectives with planapochromatic correction	191
2.10.7	Planachromats and planapochromats with increased working distances	194
2.10.8	Plansuperapochromat microscope objectives	194
2.10.9	“Microvideo” objectives	196
2.11	On Condensers of Microscopes of Transmitting Light	197
2.12	Conditions for Obtaining Uniform Light Distribution, Generated by Lighting Devices	203
2.13	Correction of Chromatic Aberration in the Optical Systems of Illumination in Microscopes	213
2.14	Features of the Construction of Lighting Devices of Microscopes for the Implementation of Methods of Contrasting	219
2.15	Examples of Phase Contrast Investigations using Different Producers of Devises	223
2.16	Several Photographs of Objects Taken using polarization and Differential Interference Contrast Microscopes	242
2.17	Investigation of the Possibility of using Leds as Light Sources in Microscopes	246

2.17.1	LED optics	250
2.17.2	LEDs in the illumination devices of microscopes	253
2.17.3	Types of diffusers and their role in lighting devices of microscopes	256
2.17.4	Led lines and matrixes in microscopes	263
2.17.5	Practice and analysis of the experimental use of the LED in the microscope	264
2.18	Technique for Calculating the Designs of Filled-type Objectives	270
2.19	Estimation of Clearances in the Design and Adjustment of Barrel Type Lens Systems	279
2.20	Experience in Creating Elements of an Automated System for Testing the Quality of Microscope Objectives	283
2.20.1	The use in the microscope of the “infinity” tube length - a step towards automating the assembly and control of microscope objectives	285
2.20.2	“Virtual” quality and assembly – steps to automate the assembly and control of microscope objectives	285
2.20.3	Elements of automation control optical-mechanical components	287
2.20.4	Elements of automation of quality control microscope objectives	289
2.21	The Concept of an Automatic Assembly Line for Microscope Objectives, Based on Adaptive Selection of their Components	292
2.21.1	Concept of an automatic assembly line for microscope objectives	293
2.21.2	Standardization of microscope objective designs	293
2.21.3	Technological errors of the elements that influence the target quality indices of microscope objectives	294
2.21.4	Adaptive-selective assembly of microscope objectives	295
2.21.5	Monitoring and ensuring the target quality indices of an microscope objective	297
2.21.6	Structural composition of the assembly line	298
2.22	Providing Target Performance Indices when Automating the Assembly of Microscope Objectives	298
2.22.1	Compensating spherical aberration by virtual assembly	299
2.22.2	Compensating coma during virtual assembly	301
2.23	False Birefringence in a Polarization Microscope	304
2.24	Interferometric Quality Control of Lenses and Objectives	312
2.24.1	Interference pattern	314
2.24.2	Control of flat surface	314
2.24.3	Control of the spherical surface	316
2.24.4	Analysis of errors of the interferometry method	317

2.24.5	High-precision processing and interpretation of complex interferograms	320
2.25	Micro-interferometer MII-4	320
2.26	Light Section Microscope PSS-3	326
2.26.1	Principle of operation	327
2.26.2	Optical diagram	330
2.27	Analysis of the Problems of Optimizing the Parameters of a Microscope's Optical System	331
2.28	Development of "Micron Resolution Microscopes" for Reducing Photolithography	341
2.28.1	Potential application of the micron photolithography system	342
2.28.2	Key parameters of the reducing photolithography objects	344
2.28.3	Concept of use microscope objective in reverse ray tracing	345
2.28.3.1	Possibility of using conventional microscope objectives for reducing photolithography purposes	347
2.28.3.2	Analysis of the possibility of creating special objectives for reduction lithography	354
2.28.4	Evolution not revolution of optical designs of lithography systems	362
2.28.5	MgF ₂ (or LiF) + Lyman's source	367
2.29	Building Lithography Optics by Mirrors	368
2.30	Concentric Mirror Objective Plan Anastigmat	375
2.31	Anamorphic Optics of Lighting Devices	382
	References	389
Chapter 3	Principles of Constructing Microscope Optics	397
3.1	Element Base and Principles of the Composition of the Optical Systems of the Microscope	397
3.1.1	Aberrational properties of a spherical surface	397
3.1.2	Optical scheme of a microscope	402
3.1.2.1	Magnifier, a simple microscope	402
3.1.2.2	Complex microscope	404
3.2	The Relationship of the Resolution of the Image Formed by the Optical System of the Microscope, with its Parameters	409
3.2.1	The resolution of the optical system of the microscope and the useful magnification of the image formed by it	409
3.3	The Quality (Q-factor) of the Microscope Optical System	412
3.4	The System of Variable Magnification in the Scheme of the Illumination Device of the Microscope	417
3.4.1	Basic schemes of optical systems with variable magnification	417
3.4.2	The position of the optically conjugate points in variable magnification optical systems	423

3.4.3	Optical system of variable magnification in the scheme of the illumination device of the microscope	426
3.5	The Construction of Frontal Components of Objectives for Microscope: Optical Design	428
3.5.1	Lens objective for microscope: what is inside?	430
3.5.2	Autocollimation method of centering lenses	432
3.5.3	Calculation of the frontal lenses of objectives for microscopes	434
3.5.4	Optical design of the frontal lenses of microscope objectives	436
3.5.5	Mechanical design and methods of assembling the frontal lenses of microscope objectives	443
3.5.6	Frontal components of the immersion objectives	450
3.6	Optical Design and Unification of Optical Systems of Objectives for Microscopes	455
3.6.1	Basic components, unification of objective optical structures	456
3.6.2	Unification of objectives for microscopes using a parametric series of focal lengths	463
3.6.3	Unification of objectives for microscopes by variants of execution	465
3.7	An Example of the Optical and Mechanical Design of a Microscope Objective	467
3.7.1	Terms of reference for the design	467
3.7.2	Patent search	469
3.7.3	Analysis of identified analogues	469
3.7.4	Prototype selection	471
3.7.5	Brief theory and practice of calculating objectives	473
3.7.5.1	Methods for calculating microscope objectives	473
3.7.6	Aberration calculation of the prototype	475
3.7.7	Dimensional and aberration calculation of a new objective	481
3.7.8	Description of the optical scheme of the new objective	486
3.7.9	Manufacturability of microscope objectives and the principle of assigning tolerances	487
3.7.10	Image quality assessment of microscope objectives	488
3.7.10.1	Evaluation of the quality of the diffraction image of the point of the two or three glued component	490
3.7.11	Assignment of tolerances for the manufacture of optical parts	495
3.7.11.1	Spherical aberration	495
3.7.11.2	Decentering	495
3.7.12	A brief description of the mechanical structures of microscope objectives	497
3.7.13	Description of the design of the developed objective	501
3.8	An Example of the Design of a Stereo Microscope	501
3.8.1	Physiological and Geometric Factors of Stereoscopic Vision	501

3.8.2	Stereoscopic effect in microscopy	504
3.8.3	Design of a stereo microscope head	512
3.9	Polarizing Stereo Microscope MPS-2	528
3.9.1	Optical system of microscope	530
3.9.2	Microscope design: MPS-2	533
3.9.3	Work in transmitted light	536
3.9.4	Work in reflected light	537
3.9.5	Work in mixed lighting	538
3.9.6	Work with counting grids	539
3.9.7	Work with microconoscopes	539
3.9.8	Some pictures of real objects	540
3.10	Comparison Microscopes	543
3.10.1	MS-51 comparison microscope	543
3.10.2	Comparison microscope for criminalists	546
3.11	Some Useful Options for Digital Imaging Systems	548
3.12	Some Examples of Digital Imaging Systems used for Metallography	550
	References	576